

Title (en)
Improved hinge for micro-mechanical device

Title (de)
Verbessertes Scharnier für mikromechanisches Gerät

Title (fr)
Charnière améliorée pour dispositif micromécanique

Publication
EP 0690329 A3 19970521 (EN)

Application
EP 95110147 A 19950629

Priority
US 26874194 A 19940630

Abstract (en)
[origin: EP0690329A2] An improved hinge (12) for a micro-mechanical device (10). The hinge is fabricated from alternating layers (12a, 12b) of different materials. A first material is selected on the basis of its amenability to fabrication processes and a second material is chosen for its strength, or some other desired characteristic, relative to the first material. <MATH>

IPC 1-7
G02B 26/08

IPC 8 full level
E05D 1/02 (2006.01); **F16C 11/04** (2006.01); **G02B 7/198** (2006.01); **G02B 26/08** (2006.01)

CPC (source: EP KR US)
E05D 1/02 (2013.01 - EP US); **G02B 26/0816** (2013.01 - EP US); **H01L 21/00** (2013.01 - KR)

Citation (search report)
• [XA] US 4793699 A 19881227 - TOKUHARA MITSUHIRO [JP]
• [DA] US 5061049 A 19911029 - HORNBECK LARRY J [US]

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US6556741B1; AU770945B2; US6571029B1; US6595624B1; US6556739B1; WO0064805A1

Designated contracting state (EPC)
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EP 0690329 A2 19960103; EP 0690329 A3 19970521; EP 0690329 B1 20010314; CA 2149931 A1 19951231; CN 1082192 C 20020403; CN 1117108 A 19960221; DE 69520306 D1 20010419; DE 69520306 T2 20010913; JP H0854555 A 19960227; KR 100344610 B1 20021129; KR 960002469 A 19960126; TW 378325 B 20000101; US 5652671 A 19970729

DOCDB simple family (application)
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